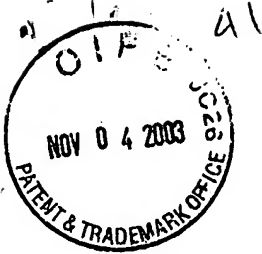


2811



Attorney Docket No. 0756-2415

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 10/026,802

Filed: December 27, 2001

For: METHOD FOR MANUFACTURING A
SEMICONDUCTOR DEVICE

) Group Art Unit: J. Im

) Examiner: 2811

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 11.3.03

Adelle M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated August 1, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 4 of this paper.

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